



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Inventor(s) : Tatsuo ENAMI *et al.*
Serial Number : 09/518,639
Filed : March 3, 2000
For : ArF EXCIMER LASER DEVICE SCANNING TYPE
EXPOSURE DEVICE AND ULTRAVIOLET LASER
DEVICE
Examiner : Jeffrey N. Zahn
Group Art Unit : 2828

RESPONSE UNDER 37 C.F.R. § 1.11

Dear Sir:

The following amendments and remarks are submitted in response to the Official action mailed August 26, 2003. The Official action set forth a three-month period for response, making this response due on or before November 26, 2003.

Please amend the above-identified application as set forth on the following pages.

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TECHNOLOGICAL CENTER 2800